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MEMS Sensors and Applications

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Message from the Guest Editor

The past two decades have witnessed substantial advances in MEMS (microelectromechanical systems) sensor technology. The emerging new field of nanotechnology and nanofabrication has allowed for the creation of a new array of MEMS sensors and transducers with remarkable properties. These MEMS sensors have seen dramatic improvements in characteristics, such as sensitivity and dynamic range, in addition to substantial miniaturization. This Special Issue invites contributions in all areas of MEMS sensors. Papers on pressure sensors, motion and acceleration sensors, microfluidic sensors, etc., are invited.



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Special Issue



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Message from the Editor-in-Chief

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